Very High Bit-Rate Distance Product Using High-Power Single-Mode 850-nm VCSEL With Discrete Multitone Modulation Formats Through OM4 Multimode Fiber

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Abstract-In order to investigate the tradeoff between optical spectral width and modulation speed of 850-nm Zn-diffusion vertical-cavity surface-emitting laser (VCSEL) and its influence on the performance of discrete multitone (DMT) modulation, two kinds of high-speed VCSEL structures with different cavity lengths $(\lambda/2 \text{ and } 3\lambda/2)$ are studied. By shortening the cavity length to $\lambda/2$, allocating the oxide layer in the standing-wave peak, and performing a Zn-diffusion aperture in our VCSEL structure, stable dual mode in the output optical spectra across the full range of bias currents with good high-speed performance (~16-GHz bandwidth) can be achieved. Compared with its multimode reference, it shows far less roll-off with regard to the maximum data rate versus transmission distance over OM4 multimode fibers under forward error correction (FEC) threshold (BER < 3.8×10^{-3}). On the other hand, for the $3\lambda/2$ VCSEL structure, by using the same Zn-diffusion conditions as those of dual-mode counterpart, highly single-mode operation (side-mode suppression ratio > 35 dB) with high available power can be achieved over the full range of bias currents. Although such device shows a smaller 3-dB electrical-tooptical bandwidth (12 versus 16 GHz) than that of the dual-mode one, it exhibits a superior transmission performance by use of DMT modulation format. A record high bit-rate distance product (107.6 Gb/s·km) at nearly 50-Gb/s transmission under FEC threshold (BER< 3.8×10^{-3}) through 2.2-km OM4 fibers has been successfully demonstrated by the use of single-mode VCSEL with optimized structures. In addition, error-free (BER < 1×10^{-12})

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transmission at 20.3 Gb/s with bit-rate distance product of 44.66 Gb/s·km has also been demonstrated.

Index Terms—OFDM modulation, semiconductor lasers, vertical cavity surface emitting lasers.

I. INTRODUCTION

▼ OST-effective interconnects (OIs) that can be operated at a high bit rate (at least 25 Gb/s by 2020 [1]) across links of >2 km will be needed in modern mega data centers [2]. To date, active optical cables (AOCs) based on 850 nm verticalcavity surface-emitting lasers (VCSELs) and multimode fibers (MMFs) appear to be the most promising solution for OIs due to the high modulation bandwidth and low power consumption [3]-[7]. By using these VCSELs and simple ON-OFF keying (OOK) modulation, transmission at >40 Gb/s across MMFs has been demonstrated. However, to realize such transmission, both high-speed optical and electrical devices will be necessary, which would thus increase the cost of OIs. Notably, aiming at 400 Gb/s Ethernet, discrete multi-tone (DMT) modulation has been reported as the most cost-effective solution (100 Gb/s imes4 channels) from the view point of optical transmitter/receiver cost reduction [8]. Moreover, compared with pulse-amplitude modulation-4 and OOK modulation, DMT modulation usually has narrower modulation bandwidth, and thus the high-speed ICs (>50 GHz) such as wide-band VCSEL driver and photoreceiver circuit are not necessary. This can further reduce the package and component cost of full AOC module. Except for speed and cost, the power consumption issue is also very important in OIs. Thanks to the remarkable advances in highperformance digital-to-analog converters and analog-to-digital converters, DMT modulation may be considered as a potential solution for OIs due to its increased availability and reduced power consumption [9], [10]. By using a 25G-class VCSEL, optical DMT transmission at >60 Gb/s in the optical back-to-back (OBTB) configuration has been demonstrated [11]. However, the transmitted bit rate drops substantially with an increase in the fiber distance due mainly to the chromatic and modal dispersion of MMFs [11]. It should be noted that the fact that larger modulation bandwidth (>40 GHz) induces more serious dispersion effect, which is the main limitation in the bit-rate distance

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product (BRDP). By narrowing down the optical spectral width, single-mode VCSELs have been reported to boost the BRDP, e.g., small aperture VCSELs [5], mode filter VCSELs [12], and photonic crystal VCSELs [13]. For small aperture VCSELs, reducing the diameter of oxide aperture (typically $2 \sim 3 \mu m$) is an effective way to suppress the higher order transverse mode (and consequently narrow down the laser linewidth) and reduce the power consumption as reported in [5]. However, small aperture VCSELs usually have limited output power, which might be insufficient for optical links approaching 2 km. For mode filter VCSELs, surface relief is used to form an integrated mode filter in order to suppress the higher order transverse mode [12]. A BRDP of 40 Gb/s·km (2 km \times 20 Gb/s) has been demonstrated using a mode filter VCSEL with multiple oxide layers [12]. The high-power Zn-diffusion single-mode VCSEL is an alternative choice to further boost the value of the BRDP [14]. Compared with the other reported single-mode VCSEL structure outlined above, it can exhibit far lower differential resistance, higher single-mode power, and can eliminate the delicate etching process of top distributed-Bragg-reflector (DBR) layers. Nevertheless, there is usually a tradeoff between VCSEL's modulation speed and its output optical spectral width [14]. The low-frequency roll-off in the single-mode VCSEL induced by serious spatial hole burning usually limits its modulation speed [14]–[16].

In this paper, two kinds of Zn-diffusion high-speed VCSEL structures with different cavity lengths ($\lambda/2$ and $3\lambda/2$) are studied in order to investigate the tradeoff between optical spectral width and modulation speed of the Zn-diffusion 850 nm VCSEL and its influence on the performance of DMT modulation. Under the same Zn-diffusion conditions and aperture size, the $3\lambda/2$ cavity VCSEL structure presents superior single-mode characteristics in terms of maximum single-mode output power and side-mode suppression ratio (SMSR) as compared to those of $\lambda/2$ counterpart at the expense of smaller modulation speed (12 versus 16 GHz). Although the single-mode device has a narrower 3-dB electrical-to-optical (E-O) bandwidth than that of dual-mode one, it exhibits a superior transmission performance by use of DMT modulation format. Record-high BRDP (107.6 Gb/s·km) at nearly 50 Gb/s transmission under FEC threshold [17] (BER < 3.8×10^{-3} [18]) across 2.2 km OM4 fiber has been successfully demonstrated by use of DMT modulation and bit-loading algorithm. These results indicate that judiciously increasing the cavity length (to $3\lambda/2$) can improve the single-mode performance of Zn-diffusion VCESL [14]. Although the modulation speed might be slightly sacrificed for such excellent single-mode performance, the DMT transmission results suggest that single-mode performance (SMSR and power) plays a far more important role in determining the maximum BRDP values than dose modulation speed.

II. DEVICE STRUCTURE AND FABRICATION

Fig. 1(a) and (b) presents the conceptual cross-sectional views of two kinds of devices for high-speed and high-power operations, respectively. These devices have the same top views, as shown in Fig. 1(c). As shown in Fig. 1(a), the epi-layer



Fig. 1. Conceptual cross-sectional views of (a) high-speed VCSEL on S.I. substrate and (b) high-power VCSEL on n^+ GaAs substrate. (c) Top-view of reported devices.

structure for the high-speed ($\lambda/2$ thick cavity) VCSEL is composed of three strained In_{0.08}Ga_{0.92}As/Al_{0.3}Ga_{0.7}As quantumwells (QWs) sandwiched between a 36-pair n-type and a 26-pair p-type Al_{0.9}Ga_{0.1}As/ Al_{0.12}Ga_{0.88}As DBR layers with an Al_{0.98}Ga_{0.02}As layer just above the MQWs for electrical and optical confinement (oxidation). The entire structure was grown on a semi-insulating (S.I.) GaAs substrate to mitigate the parasitic *RC*-limited bandwidth. Here, the cavity length was shortened to $\lambda/2$ in order to reduce the internal carrier transient time and increase the optical confinement factor [5]. Strained QWs were employed in the high-speed VCSEL in order to increase the differential gain, and thereby improve the high-speed characteristics of the VCSEL [19].

As shown in Fig. 1(b), the epi-layer structure for the high-power ($3\lambda/2$ thick cavity) VCSEL is composed of three unstrained GaAs/Al_{0.3}Ga_{0.7}As QWs sandwiched between 30-period n-type and 20-period p-type Al_{0.9}Ga_{0.1}As/Al_{0.12} $Ga_{0.88}$ As DBR layers with an $Al_{0.98}Ga_{0.02}$ As layer just above the MQWs for oxidation. There are four major differences in the epi-layer structure between the high-speed and the highpower VCSELs. First, the epi-layer structure is grown on an n⁺ GaAs substrate, rather than an S.I. substrate. This is because n⁺ substrates can provide better heat-sinking for high-power operation than that of S.I. substrates. In addition, the parasitic RC-limited bandwidth is not the main factor limiting the modulation bandwidth in high-power single-mode VCSELs. Their speed performance is usually limited by spatial hole burning effect, as discussed in [14]–[16]. Second, cavity length is enlarged to $3\lambda/2$ to dilute the optical confinement and increase the saturation power. Third, we employed GaAs/Al_{0.3}Ga_{0.7}As QWs in the high-power VCSEL due to their larger density state as compared to that of In_{0.08}Ga_{0.92}As QWs in the high-speed VCSEL, which might benefit the high-power performance. Fourth, the currentconfined layer of the high-power VCSEL is located near a node in the cavity standing wave profile where the optical intra-cavity scattering loss is reduced and thereby improves the high-power



Fig. 2. *L–I–V* characteristics of (a) device A and (b) device B at 25 °C. Optical spectra of (c) device A and (d) device B under various bias currents. (device A: $D_Z/W_Z/W_O = 1.6/6/9 \ \mu$ m; device B: $D_Z/W_Z/W_O = 1.2/7/7 \ \mu$ m).

performance. In contrast, for the high-speed VCSEL, the oxide aperture is located at the standing wave peak in the cavity where the optical confinement is increased and thereby benefits its high-speed performance and reduces the threshold current.

Oxide-relief and Zn-diffusion techniques are used in both high-speed and high-power VCSELs. By the use of the chemical solution, the single $Al_x O_{1-x}$ current confined layer is selectively removed without degrading the device performances [7], [14]. Due to the fact that the refractive index of air is much smaller than that of the $Al_x O_{1-x}$ layer (1 versus 1.55), the parasitic capacitance can be further reduced [7]. The Zn-diffusion process is applied to the top DBR of the VCSEL in order to reduce device resistance and manipulate the number of transverse modes [7], [14], [15]. The lasing modes are suppressed by the Zn-diffused DBR region. The threshold gain will become higher due to the increase in free-carrier absorption loss and the decrease in reflectivity after the diffusion (DBR disordering) process [7], [15]. The Zn-diffusion and oxide-relief processes have been explained in more detail elsewhere [7], [14], [15]. During device fabrication, three important parameters can be controlled: D_Z , W_Z , and W_O , representing the Zndiffusion depth, aperture diameter, and the oxide-relief aperture diameter, respectively. During processing, the high-speed ($\lambda/2$) and high-power $(3\lambda/2)$ epitaxial wafers are separately diced into two different pieces for each device structure. Table I lists the cavity lengths and the geometric sizes of high-speed (device A and device B) and high-power (device C and device D) VCSELs.

TABLE I GEOMETRIC SIZE OF THE STUDIED DEVICES

Device		Cavity	$D_{\rm Z}~(\mu{\rm m})$	$W_{\rm Z}~(\mu{ m m})$	$W_{\rm O}~(\mu{ m m})$
High-speed	A^1	λ/2	1.6	6	9
	\mathbf{B}^1	$\lambda/2$	1.2	7	7
High-power	C^2	3λ/2	1.6	6	9
	D^2	3λ/2	1.2	7	4

 D_Z : Depth of Zn-diffusion aperture. W_Z : Width of Zn-diffusion aperture. W_O : Width of oxide-relief aperture.

III. HIGH-SPEED VCSEL

Fig. 1(a) presents a conceptual cross-sectional view of the high-speed VCSEL. Fig. 2(a) and (b) illustrates the powercurrent-voltage (L-I-V) characteristics of high-speed devices A and B at 25 °C, respectively. The threshold current (I_{th}) and differential resistance (R_{diff}) are also specified in Fig. 2(a) and (b). It should be noted that the optical power values presented in this work include a coupling loss of approximately 2 dB between the VCSEL and MMF fiber. As can be seen, by further increasing Zn-diffusion depth (D_Z) and reducing Zn-diffusion aperture diameter (W_Z) , device A has higher threshold current (1.2 versus 0.9 mA), lower saturated power (1.6 versus 1.8 mW) and smaller resistance (90 versus 98 Ω) than device B. This is consistent with our previous results [7]. Fig. 2(c) and (d) presents the measured optical spectra of devices A and B under various bias currents at 25 °C. As can be seen, thanks to the Zn-diffusion



Fig. 3. Measured E-O frequency responses of (a) device A and (b) device B under various bias currents. (device A: $D_Z/W_Z/W_O = 1.6/6/9 \ \mu$ m; device B: $D_Z/W_Z/W_O = 1.2/7/7 \ \mu$ m).



Fig. 4. Experiment setup.

aperture in our VCSEL for optical mode control [7], [14], device A can exhibit dual-mode performance under bias current >4.5 mA even with a large diameter of oxide aperture (~9 μ m), which can benefit the transmission performance. Fig. 3(a) and (b) illustrates the measured E-O responses of devices A and B under various bias currents, respectively. As can be seen, the low-frequency roll-off in typical single-mode VCSEL induced by the spatial hole burning effect [14]–[16] is not significant in our dual-mode VCSEL structure. This can be attributed to a reduction in internal carrier transient time in the short cavity (λ /2). Furthermore, a tradeoff between spectral width and modulation speed can be observed in these two devices (A and B). The maximum modulation speed of devices A and B are 16 and 20 GHz, respectively. For DMT transmission, we optimized the bias cur-



Fig. 5. SNR versus frequency with bit-loading using (a) device A and (b) device B across OM4 fibers and in OBTB configuration. (c) Data rates and percentage of residual data rate versus transmission distance. (device A: $D_{Z/}W_Z/W_O = 1.6/6/9 \ \mu$ m; device B: $D_{Z/}W_Z/W_O = 1.2/7/7 \ \mu$ m).



Fig. 6. Constellations of (a) device A and (b) device B after 1 km OM4 fibers. (device A: $D_{Z/}W_Z/W_O = 1.6/6/9 \ \mu$ m; device B: $D_{Z/}W_Z/W_O = 1.2/7/7 \ \mu$ m).

rents as follows: device A (4.5 mA) and device B (6 mA). It should be noted that the bias currents of the four devices were optimized by running the DMT system over 1 km MMF.

Fig. 4 illustrates the experiment setup of DMT transmission. The baseband electrical DMT signal was generated using offline



Fig. 7. *L–I–V* characteristics of (a) device C and (b) device D at 25 °C. Optical spectra of (c) device C and (d) device D under various bias currents. (Device C: $D_Z/W_Z/W_O = 1.6/6/9 \ \mu$ m; device D: $D_Z/W_Z/W_O = 1.2/7/4 \ \mu$ m).

MATLAB with the parameters set as follows: fast Fourier transform size of 512, cyclic prefix of 1.5%, and the subcarrier number of 138. The electrical DMT signal was then generated using an arbitrary waveform generator (Tektronix AWG70001A) at a sampling rate of 50 GSample/s corresponding to a signal bandwidth of 13.5 GHz, and the digital-to-analog conversion resolution and the output peak-to-peak voltage (V_{pp}) were 10 bit and 500 mV, respectively. An electrical amplifier (Picosecond 5867) and an attenuator were used to optimize the optical modulation index for each device. The DMT signal was fed into the high-speed VCSELs through a 26.5 GHz bias-T (Agilent 11612A) via a GS probe. The output light was buttcoupled into a lensed fiber with a core diameter of 62.5 μ m and coupling efficiency of approximately 60%. After the OM4 fiber transmission, the optical DMT signal was directly detected using a 9.5 GHz photoreceiver (PICOMETRIX PT-12B). The DMT signal was retrieved and digitized using a real-time oscilloscope (Tektronix DSA71604) with a sample rate of 50 GSample/s and a 3-dB bandwidth of 16 GHz. Demodulation was performed using offline MATLAB DSP programs. The signal-to-noise ratio (SNR) was estimated after demodulation, and the BERs were measured based on a bit-by-bit comparison between transmitted and received data.

Fig. 5(a) and (b) plots the SNR versus frequency of the DMT signal with bit-loading using device A and device B over various transmission distances, respectively. By combining DMT modulation with bit-loading algorithm, we can maximize the data rate and maintain the BER below the FEC threshold of

 3.8×10^{-3} . The achieved data rates over various transmission distances are listed in Fig. 5(a) and (b). By the use of device A, the achieved BRDPs are 47 and 58.2 Gb/s·km for 1 and 1.5 km OM4 fibers, respectively. Fig. 5(c) presents the data rates and the percentage of residual data rate versus transmission distance. As can be seen, device A achieves a better transmission (>200 m) performance than device B due to its smaller number of transverse modes. In addition, data rates were shown to drop more with an increase in transmission distance >1 km, due to the serious chromatic and modal dispersion of MMFs, as shown in Fig. 5(c). These DMT transmission results suggest that reducing the number of transverse modes and ultimately achieving single-mode behavior may be the key to extending transmission distance (>2 km OM4 fibers) and achieving a higher BRDP. Fig. 6(a) and (b) shows the constellations for device A and device B after 1 km OM4 fibers.

IV. HIGH-POWER VCSEL

In order to extend the maximum transmission distance in OM4 fibers (>2 km [2]), we sought to optimize the geometric sizes $(D_Z, W_Z, \text{ and } W_O)$ of our VCSELs with the objective of achieving high-power, single-mode performance. The key to achieving single-mode performance is the suppression of high-order transverse modes in the current-confined region of the VCSEL cavity by employing a Zn-diffusion aperture. Therefore, we must let $W_O > W_Z$ to cause a significant Zn-diffusion induced loss in the current-confined regime. As described in our



Fig. 8. Measured E-O frequency responses of (a) device C and (b) device D under various bias currents. (Device C: $D_Z/W_Z/W_O = 1.6/6/9 \ \mu$ m; device D: $D_Z/W_Z/W_O = 1.2/7/4 \ \mu$ m).

previous work [14], the Zn-diffusion aperture diameter (W_Z) in the epi-layer structure must be smaller than 6.5 μ m to ensure single-mode performance. The geometric sizes $(D_Z, W_Z, \text{ and } W_Z)$ W_O) of device C and device D are listed in Table I. Fig. 7(a) and (b) illustrates the L-I-V characteristics of devices C and D at 25 °C, respectively. As can be seen, device C exhibits small differential resistance ($\sim 80 \Omega$), reasonable threshold current (1.9 mA) and large saturated power ($\sim 3.3 \text{ mW}$) as compared to device D, which can be attributed to the optimization in the geometric sizes of the VCSEL structure. Fig. 7(c) and (d) presents the measured optical spectra of device C and device D under various bias currents at 25 °C, respectively. As can be seen, device C can maintain single-mode performance with SMSR of >35 dB under a full range of bias currents. Fig. 8(a) and (b) illustrates the measured E-O responses of device C and device D under various bias currents, respectively. A reasonable high-speed performance (~12 GHz) with minimal low-frequency roll-off can be achieved using device C. Minimization of the low-frequency roll-off induced by spatial hole burning can be attributed to the optimization of the geometric structure in our Zn-diffused VC-SEL, as discussed in our previous work [14]. In addition, the ringing in measured traces of this highly single-mode device can be attributed to the optical feedback effect, which should be more significant in the single-mode device than the multimode one, due to its much longer coherent time [20]. In order to suppress the feedback effect, an optical isolator is usually integrated with a single-mode laser during high-speed operations and data transmission [21]. As shown in Fig. 8(b), device D has a reasonable maximum 3-dB E-O bandwidth (\sim 14.5 GHz), despite its low threshold current. Again we can see the tradeoff between spectral width and modulation speed, as in the cases of devices A and B. The fact that the E-O bandwidth of the singlemode device is smaller than that of the MM reference has been attributed to less damping in its E-O frequency response and more serious low-frequency roll-off [14], [16], [22]. A more detailed theoretical [23] work to investigate such phenomenon would be our future work. For DMT transmission, we choose 8 and 4.5 mA for devices C and D, respectively. It should be noted that these bias currents were also optimized using the methods outlined above.

The experiment setup for the high-power VCSEL resembles that of the high-speed VCSEL. Fig. 9(a) and (b) presents the SNR versus frequency of the DMT signal with bit-loading using device C and device D over various transmission distances, respectively. The achieved data rates over various transmission distances are listed in Fig. 9(a) and (b). By using our high-power single-mode VCSEL (device C), we have successfully achieved a record-high BRDP of 107.6 Gb/s·km (2.2 km × 48.92 Gb/s) with BER of $< 3.8 \times 10^{-3}$. Fig. 9(c) presents the data rates and percentage of residual data rate versus transmission distance. By using device C, it shows very small roll-off in the maximum data rate with an increase in transmission distance due to its highly single-mode performance. Fig. 10(a) and (b) presents the constellations for devices C and D after 2.2 km and 1 km OM4 fibers, respectively.

We also demonstrate error-free transmission (defined as a BER of $< 1 \times 10^{-12}$) for device C. The bias current is fixed at 8 mA. Fig. 11(a) presents the SNR versus frequency of the DMT signal with bit-loading using device C. By using bit-loading algorithm, the employed signal bandwidth was decreased to \sim 8.5 GHz due to the lower target BER. A BRDP as high as 44.66 Gb/s·km (2.2 km × 20.3 Gb/s) was successfully achieved with BER of $< 1 \times 10^{-12}$. It should be noted that the error-free performance was confirmed by measured SNR due to the difficulties associated with direct measurement of such small BER values. To the best of our knowledge, BRDP of 44.66 Gb/s·km is the highest reported for error-free (BER $< 1 \times 10^{-12}$) operations [12]. Fig. 11(b) presents the data rates and percentage of residual data rate versus transmission distance. As can be seen, the data rate also drops at a very slow rate with an increase in fiber distance. Fig. 11(c) presents the constellations of device C for 2.2 km error-free transmission in OM4 fiber.

V. CONCLUSION

In summary, we have demonstrated optical DMT transmission using two kinds of Zn-diffusion 850 nm VCSELs with different cavity lengths ($\lambda/2$ and $3\lambda/2$). By shortening the cavity length to $\lambda/2$, placing a current-confined layer to the peak in the cavity standing wave profile, and performing Zn-diffusion process, the dual-mode performance can be achieved under



Fig. 9. SNR versus frequency with bit-loading using (a) device C and (b) device D through OM4 fibers and in OBTB configuration. (c) Data rates and percentage of residual data rate versus transmission distance. (Device C: $D_Z/W_Z/W_O = 1.6/6/9 \ \mu$ m; device D: $D_Z/W_Z/W_O = 1.2/7/4 \ \mu$ m).

a full range of bias currents with high 3-dB E-O bandwidth (16 GHz). Compared with the multimode reference, it shows far less roll-off in the maximum data rate with an increase in transmission distance. On the other hand, by applying the same Zn-diffusion conditions, a high-power (>3 mW) highly single-mode (SMSR> 35 dB) VCSEL with $3\lambda/2$ thick cavity can be achieved. Thanks to its excellent single-mode performance, record-high BRDP (107.6 Gb/s·km) at nearly 50 Gb/s



Fig. 10. Constellations of (a) device C after 2.2 km OM4 fibers and (b) device D after 1 km OM4 fibers. (Device C: $D_{Z/}W_Z/W_O = 1.6/6/9 \ \mu$ m; device D: $D_{Z/}W_Z/W_O = 1.2/7/4 \ \mu$ m).



Fig. 11. SNR versus frequency using device C for error-free transmission through OM4 fibers and in OBTB configuration. (b) Data rates and percentage of residual data rate versus transmission distance. (c) Constellations of device C across 2.2 km OM4 fiber. (Device C: $D_{Z/}W_Z/W_O = 1.6/6/9 \,\mu$ m).

transmission at BER< 3.8×10^{-3} across 2.2 km OM4 fiber has been successfully achieved by using DMT modulation with bit-loading algorithm. Although the modulation speed might be slightly sacrificed to achieve such excellent single-mode performance, the DMT transmission results suggest that singlemode performance is far more important than high modulation speed with regard to achieving high BRDP. For the error-free (BER< 1×10^{-12}) DMT transmission, a record-high BRDP (44.66 Gb/s·km) has also been successfully demonstrated.

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